



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit: 2815  
Examiner: Mr. Joseph H. Nguyen

In re PATENT APPLICATION of:

Applicant : Takashi NOGUCHI )  
Serial No. : 10/822,691 )  
Filed : April 13, 2004 )  
For : HEAT RADIATION STRUCTURE )  
OF SEMICONDUCTOR DEVICE, )  
AND MANUFACTURING )  
METHOD THEREOF )  
Attorney Ref. : OKI 419 )

AMENDMENT

September 22, 2005

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This is responsive to the Office Action of May 24, 2005, the period for reply to which is being extended to expire on September 24, 2005 by a Petition filed concurrently herewith.

A fee of \$ 300 is being submitted concurrently. Should this remittance be accidentally missing, however, or should any additional fees be needed (including extension of time fees, since Applicant hereby provisionally petitions for any extensions that may be deemed necessary to avoid abandonment), the Director may charge such fees to our Deposit Account number 18-0002.

Please amend the above-identified application as specified on the following pages, and then reconsider the application in view of the Remarks that are presented thereafter.

FEE ENCLOSED: \$ 300  
Please charge any further  
fee to our Deposit Account  
No. 18-0002